EAST Search History

EAST Search History (Prior Art)

Ref #	Hits	Search Query	DBs	Default Operator	Plurals	Time Stamp
S108	1441	703/13.ccls.	USPAT	OR	OFF	2011/07/25 11:54
S109	2069	703/13.ccls.	US-PGPUB; USPAT	OR	OFF	2011/07/25 11:54
S110	936	703/7.ccls.	US-PGPUB; USPAT	OR	OFF	2011/07/25 11:54
S111	809	438/5.ccls.	US-PGPUB; USPAT	OR	OFF	2011/07/25 11:54
S112	0	S111 and ((model$4 simulat$4) with (semiconductor near2 (tool assembly manufactur$4 equipment)) with (distributed adj simulat$4)).clm.	US-PGPUB; USPAT	OR	OFF	2011/07/25 11:55
S113	4	S111 and ((model$4 simulat$4) with (semiconductor near2 (tool assembly manufactur$4 equipment))).clm.	US-PGPUB; USPAT	OR	OFF	2011/07/25 11:56
S114	0	S111 and ((model$4 simulat$4) with (semiconductor near2 (tool assembly manufactur$4 equipment) with (((re adj use)lookup) with result solution)).clm.	US-PGPUB; USPAT	OR	OFF	2011/07/25 11:57
S115	0	S109 and ((model$4 simulat$4) with (semiconductor near2 (tool assembly manufactur$4 equipment) with (((re adj use)lookup) with result solution)).clm.	US-PGPUB; USPAT	OR	OFF	2011/07/25 11:57
S116	0	S110 and ((model$4 simulat$4) with (semiconductor near2 (tool assembly manufactur$4 equipment) with (((re adj use)lookup) with result solution)).clm.	US-PGPUB; USPAT	OR	OFF	2011/07/25 11:57
S117	0	(S109 OR S110) and ((model$4 simulat$4) with (semiconductor near2 (tool assembly manufactur$4 equipment) with (distributed adj simulat$4)).clm.	US-PGPUB; USPAT	OR	OFF	2011/07/25 11:57
S118	916	(S109 S110 S111) and ((model$4 simulat$4) with (grid mesh$4 element))	US-PGPUB; USPAT	OR	OFF	2011/07/25 11:58
S119	118	(S109 S110 S111) and ((model$4 simulat$4) with (grid mesh$4 element) with (geometr$4))	US-PGPUB; USPAT	OR	OFF	2011/07/25 11:59
S120	2858	700/121.ccls.	US-PGPUB; USPAT	OR	OFF	2011/07/25 11:59
S121	0	S120 and ((model$4 simulat$4) with (semiconductor near2 (tool assembly manufactur$4 equipment)) with (distributed adj simulat$4)).clm.	US-PGPUB; USPAT	OR	OFF	2011/07/25 12:00
S122	55	S120 and ((model$4 simulat$4) with (semiconductor near2 (tool assembly manufactur$4 equipment))).clm.	US-PGPUB; USPAT	OR	OFF	2011/07/25 12:00
S123	0	S120 and ((model$4 simulat$4) with (semiconductor near2 (tool assembly	US-PGPUB; USPAT	OR	OFF	2011/07/25 12:01

		manufactur$4 equipment)) with (((re adj use)lookup) with result solution)).clm.				
S124	156	(S120) and ((model$4 simulat$4) with (grid mesh$4 element))	US-PGPUB; USPAT	OR	OFF	2011/07/25 12:01
S125	8	(S120) and ((model$4 simulat$4) with (grid mesh$4 element) with (semiconductor near2 (tool assembly manufactur$4 equipment)))	US-PGPUB; USPAT	OR	OFF	2011/07/25 12:02
S127	0	(S109 S110 S111 S120) and ((model$4 simulat$4) with (semiconductor near2 (tool assembly manufactur$4 equipment)) with (((re adj use) lookup) with result solution)).clm.	US-PGPUB; USPAT	OR	OFF	2011/07/25 12:04
S128	627	((STRANG).inv. OR (MITROVIC).inv.	US-PGPUB; USPAT	OR	OFF	2011/07/25 12:05
S129	162	((ERIC near2 STRANG).inv. OR (ANDREJ near2 MITROVIC).inv.	US-PGPUB; USPAT	OR	OFF	2011/07/25 12:06
S130	9	(S109 S110 S111 S120) and ((model$4 simulat$4) with (semiconductor near2 (tool assembly manufactur$4 equipment)) with (grid cell geometr$4 (physical adj geometr$4))).clm.	US-PGPUB; USPAT	OR	OFF	2011/07/25 12:11
S131	2	700/29-31.ccls. and ((model$4 simulat$4) with (semiconductor near2 (tool assembly manufactur$4 equipment)) with (grid mesh element))	US-PGPUB; USPAT	OR	OFF	2011/07/25 12:14
S132	1	700/29-31.ccls. and ((model$4 simulat$4) with (semiconductor near2 (tool assembly manufactur$4 equipment)) with (distribut$4 with (model$4 simulat$4 execut$4)))	US-PGPUB; USPAT	OR	OFF	2011/07/25 12:14
S133	8	"438"/$.ccls. and ((model$4 simulat$4) with (semiconductor near2 (tool assembly manufactur$4 equipment)) with (distribut$4 with (model$4 simulat$4 execut$4)))	US-PGPUB; USPAT	OR	OFF	2011/07/25 12:15
S134	0	700/95.ccls. and ((model$4 simulat$4) with (semiconductor near2 (tool assembly manufactur$4 equipment)) with (grid mesh element))	US-PGPUB; USPAT	OR	OFF	2011/07/25 12:16
S135	899	700/95.ccls.	US-PGPUB; USPAT	OR	OFF	2011/07/25 12:17
S136	1431	703/22.ccls.	US-PGPUB; USPAT	OR	OFF	2011/07/25 12:17
S137	79	(semiconductor near3 (process$4 too154 equipment manufactur$4)) and ((model$4 simulat$4) with((physical geometry) near2 (machine tool manufactur$4 assembly))) and ((parallel near3 process$4) (code adj parallel$8) ((plural distributed multiple) near4 simulat$4) grid)	US-PGPUB; USPAT	OR	OFF	2011/07/25 12:18
S138	0	(semiconductor near3 (process$4 too154 equipment manufactur$4)) and ((model$4 simulat$4) with ((physical geometry) near2 (machine tool manufactur$4 assembly))) and (("re" adj (using use)) with (known startS4 precomputed stor$4) with (result solution output))	US-PGPUB; USPAT	OR	OFF	2011/07/25 12:22

S139	0	(semiconductor near3 (process$4 too154 equipment manufactur$4)) and ((model$4 simulat$4) with ((physical geometry) near2 (machine tool manufactur$4 assembly))) and (("re" adj (using use)) with (known start$4 precomputed stor$4) with (result solution output))	US-PGPUB; USPAT; USOCR; FPRS; EPO; JPO; DERWENT; IBM_TDB	OR	OFF	2011/07/25 12:22
S140	15	(semiconductor near3 (process$4 too154 equipment manufactur$4)) with ((model$4 simulat$4) with ((physical geometry) near2 (machine tool manufactur$4 assembly)))	US-PGPUB; USPAT; USOCR; FPRS; EPO; JPO; DERWENT; IBM_TDB	OR	OFF	2011/07/25 12:23
S148	29	US-5526293-$.DID. OR US-5583780-$.DID. OR US-5866437-$.DID. OR US-6304834-$.DID. OR US-20020107604-$.DID. OR US-20030078738-$.DID. OR US-20030101251-$.DID. OR US-6571371-$.DID. OR US-6560503-$.DID. OR US-20030135302-$.DID. OR US-6587744-$.DID. OR US-6628809-$.DID. OR US-6643616-$.DID. OR US-20040078319-$.DID. OR US-6728591-$.DID. OR US-20040102934-$.DID. OR US-6757645-$.DID. OR US-6763277-$.DID. OR US-6774998-$.DID. OR US-6810296-$.DID. OR US-6812045-$.DID. OR US-20050010319-$.DID. OR US-20050016947-$.DID. OR US-6905895-$.DID. OR US-7055112-$.DID. OR US-7184850-$.DID. OR US-7333871-$.DID. OR US-7356377-$.DID. OR US-7622308-$.DID.	US-PGPUB; USPAT	OR	OFF	2011/07/26 12:28

EAST Search History (Interference)

Ref #	Hits	Search Query	DBs	Default Operator	Plurals	Time Stamp
S141	0	438/5.ccls. and ((model$4 simulat$4) with (semiconductor near2 (tool assembly manufactur$4 equipment)) with (distributed adj simulat$4)).clm.	USPAT; UPAD	OR	OFF	2011/07/25 12:25
S142	0	438/5.ccls. and ((model$4 simulat$4) with (semiconductor near2 (tool assembly manufactur$4 equipment)) with (((re adj use) lookup) with result solution)).clm.	USPAT; UPAD	OR	OFF	2011/07/25 12:26
S143	0	438/5.ccls. and ((model$4 simulat$4) with (semiconductor near2 (tool assembly manufactur$4 equipment)) with (((re adj use) lookup) with result solution)).clm.	USPAT; UPAD	OR	OFF	2011/07/25 12:26
S144	0	703/7,13,22.ccls. and ((model$4 simulat$4) with (semiconductor near2 (tool assembly manufactur$4 equipment)) with (((re adj use) lookup) with result solution)).clm.	USPAT; UPAD	OR	OFF	2011/07/25 12:26
S145	0	703/7,13,22.ccls. and ((model$4 simulat$4) with (semiconductor near2 (tool assembly manufactur$4 equipment)) with (((re adj use) lookup) with result solution)).clm.	USPAT; UPAD	OR	OFF	2011/07/25 12:27
S146	0	703/7,13,22.ccls. and ((model$4 simulat$4) with (semiconductor near2 (tool assembly	USPAT; UPAD	OR	OFF	2011/07/25 12:27

		manufactur$4 equipment)) with (((re adj use) lookup) with result solution)).clm.				
S147	0	700/121.ccls. and ((model$4 simulat$4) with (semiconductor near2 (tool assembly manufactur$4 equipment) with (((re adj use) lookup) with result solution)).clm.	USPAT; UPAD	OR	OFF	2011/07/25 12:27

7/26/2011 2:48:56 PM
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